



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoo, Woo Sik  
Assignee: WaferMasters, Inc.  
Title: Method for Ultra-Thin Film Formation  
Serial No.: 09/775,835 Filing Date: January 31, 2001  
Examiner: Lisa A. Kilday Group Art Unit: 2829  
Docket No.: M-8250 US

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Irvine, California  
August 21, 2003

RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

In response to the Final Office Action dated May 21, 2003, Applicants submit the following amendments and remarks.

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